

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 294550US41PCT		SERIAL NO. 10/588,703	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Jean DIJON, et al.			
		FILING DATE		GROUP			
		August 8, 2006		1715			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Office Action issued May 10, 2011, in Japan Patent Application No. 2006-551895, filed April 28, 2011, (with English-language Translation).					
	AX	C.M. Cotell, et al., "Microstructural Development of Thin Films Grown by Pulsed Laser Deposition," <i>Materials Science and Engineering B</i> 32 (1995) 221-230.					
	AY	Masako Yudasaka et al., "Specific Conditions for Ni Catalyzed Carbon Nanotube Growth by Chemical Vapor Deposition," <i>Appl. Phys. Lett.</i> 67 (17) October 23, 1995.					
	AZ				<input type="checkbox"/> Additional References sheet(s) attached		
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							